

## Transaction Information

Tool ID	LASC765
Tool Status	Running Wafers
Location	Singapore
Wafer Size	300 mm
Fab Section	Lithography
Tool Available Date	2025-11-30

## General Product Information

Vendor Supplier	ASML
Model	XT1900Gi
Vintage	2008
Serial No	5884
Asset Description	193nm Immersion scanner
Software Version	5.1
CIM	secs
Process	40/45nm

## Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Handler System	wfr handler		OK
Factory Interface	FOUP	1	OK
Options System			
Others			
Main System	main body	1	OK

## Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
MCWC	1	OK
WISR	1	OK
body	1	OK
MDC	1	OK
LCWC	1	OK
laser	1	OK
WICR	1	OK
filter cabinet	1	OK
ACC	1	OK

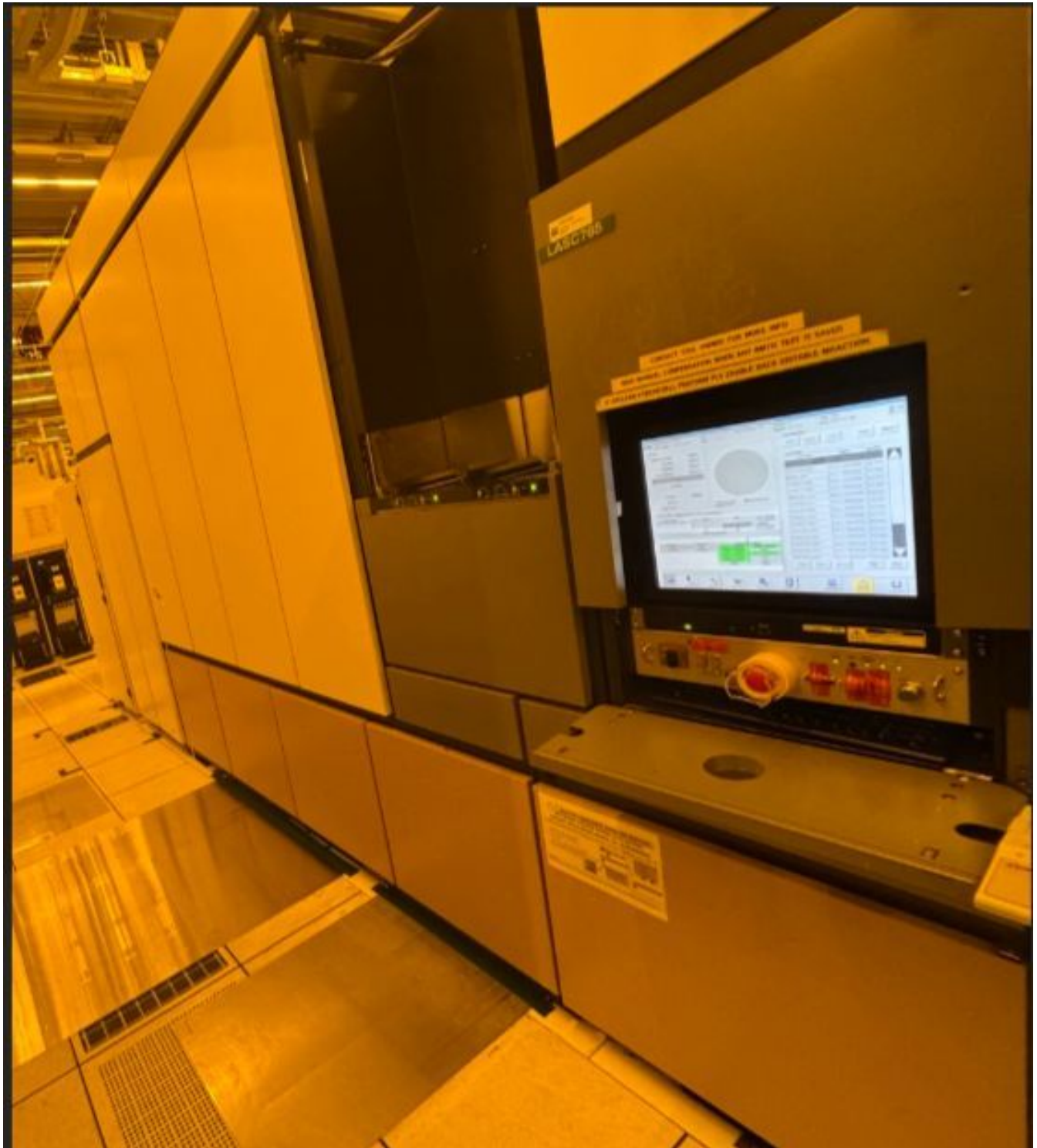
## Missing/Faulty Parts / Accesories List

Description	Quantity
NONE	

# Tool Pictures

General

Scanner body



Hardware Sub-fab

ACC, filter cabinets, Cymer laser,  
MDC, LCWC, MCWC cabinets , WICR,  
WISR cabinets



1000011794.jpg

Hardware Sub-fab

ACC, filter cabinets, Cymer laser,  
MDC, LCWC, MCWC cabinets , WICR,  
WISR cabinets



MDC\_WISC\_WICC.png

Hardware Sub-fab

ACC, filter cabinets, Cymer laser,  
MDC, LCWC, MCWC cabinets , WICR,  
WISR cabinets



Hardware Sub-fab

ACC, filter cabinets, Cymer laser,  
MDC, LCWC, MCWC cabinets , WICR,  
WISR cabinets



LCWC\_MCWC.png

Manufacture Serial

NONE

 **ASML**

**CE**

DE RUN 6501  
5504 DR VELDHOVEN  
THE NETHERLANDS

MACHINE TYPE : XTIII / 1900G1

12NC : 9428.999.65710

SERIAL NO. : 5884

MANUFACTOR DATE : 02-2008

LASC765



## Additional Tool Data Files